



Form 1449*

**INFORMATION DISCLOSURE STATEMENT
IN AN APPLICATION**

Docket Number: G&C 30566.196-US-01

Application Number: 09/925,597

Applicant: Eric Yves Theriault et al.

Filing Date: August 9, 2001

Group Art Unit: 2155

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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FOREIGN PATENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
711	EP 0 959 587 A2	24/11/99	Europe				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

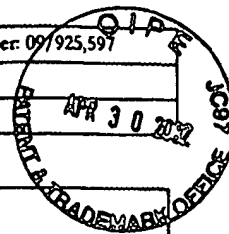
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Form 1449 ^o	Docket Number: G&C 30566.196-US-01	Application Number: 09/925,597
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71L	5,471,592	11/28/95	Gove et al.			

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	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES NO
71L	0 316 956 A2	05/24/89	EPO			
71L	WO 90/05422	05/17/90	PCT US			
71L	0 535 807 A2	04/07/93	EPO			
71L	WO 00/58856	10/05/00	PCT US			

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[illegible]

EXAMINER: <u>Kerry Li</u>	DATE CONSIDERED: <u>4/20/05</u>
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